

Company Contacts:

Katsutomo Terashima
Gigaphoton, Inc.
Tel: +81-285-28-8410
Fax: +81-285-28-8439
E-mail: katsutomo_terashima@gigaphoton.com

Yutaka Katsuki
Gigaphoton, Inc.
Tel: +81-285-28-8415
Fax: +81-285-28-8439
E-mail: sales@gigaphoton.com

**GIGAPHOTON'S DR. HAKARU MIZOGUCHI TO DELIVER EUV UPDATE
AT THE 2011 IEEE NANOTECHNOLOGY COUNCIL EVENT ON NOVEMBER 15**

Dr. Mizoguchi will also Participate on the Panel, "Challenges and Breakthroughs in Photonics"

OYAMA, JAPAN; November 8, 2011 — Gigaphoton Inc., a major lithography light source manufacturer, today announced that Chief Technology Officer Dr. Hakaru Mizoguchi will deliver his presentation, "New Light at the End of the EUV Tunnel," at the 2011 IEEE Nanotechnology Council's Seventh Annual Half-day Symposium on Nanophotonics and Imaging. In addition, Dr. Mizoguchi is one of several experts that will participate in the "Challenges and Breakthroughs in Photonics" panel event. The symposium will take place at the Texas Instruments Auditorium in Santa Clara, Calif.

"I am honored to represent Gigaphoton in this key industry event as a panelist and to present our progress with laser-produced plasma (LPP) light sources for EUV lithography for high-volume manufacturing. Also, I will deliver recent data on Gigaphoton's unique technology solutions for on-demand Sn target droplet supply, solid-state laser pre-pulse and debris mitigation using magnetic fields."

The 2011 IEEE Nanotechnology Council's Seventh Annual Half-day Symposium on Nanophotonics and Imaging will take place on Tuesday, November 15, from noon until 5:00 p.m. at the Texas Instruments Auditorium E-1 located at 2900 Semiconductor Drive in Santa Clara, Calif. To RSVP to the event, please visit the IEEE website at: <http://www.ieee.org/nano>

Members of the press that would like to schedule a meeting with Dr. Hakaru Mizoguchi before or during the symposium may contact Angie Kellen at: akellen@mcapr.com or phone: 650-968-8900 ext. 120.

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Agenda for Dr. Mizoguchi on November 15:

2:40 – 3:20 p.m.: Session C:

Dr. Hakaru Mizoguchi, CTO of Gigaphoton, “New Light at the End of the EUV Tunnel”

4:10 – 4:50 p.m.: Session E:

Panel – “Challenges & Breakthroughs in Photonics”

Moderator: Ed Sperling, Editorial Director – *Semi MD*

Panelists: Dr. Hughes Metras – Leti

Dr. Hakaru Mizoguchi – Gigaphoton

Dr. Chanmin Su – Dir of Tech, AFM Business Unit, Bruker-Nano, Inc.

Dr. Xiang Zhang – UC Berkeley

About Gigaphoton:

Since its founding in 2000, Gigaphoton has developed and delivered user-friendly, high-performance DUV laser light sources used at major semi-conductor chipmakers in the Pan-Asian, US, and European regions. Gigaphoton's patented, innovative LPP EUV technology solutions will lead the way to a cost-effective, highly productive lithography source for high-volume production. With a global business outlook, Gigaphoton strives to be the world's number one lithography light source provider, focusing on end-user needs in every phase of its business, from research and development to manufacturing to best-in-class reliability and world-class customer support. See <http://www.gigaphoton.com>.